MEMORANDUM OF UNDERSTANDING

between

Sepehr Art University in Isfahan, Isfahan Province, Iran

and

Akademia Sztuki w Szczecinie, Pl. Orła Białego 2, 70-562 Szczecin, Poland

The **Sepehr Art University in Isfahan and Academia Sztuki w Szczecinie**, wishing to promote co-operation between the two institutions in education and in academic research, agree to explore:

a. co-operation on academic programmes,
b. the development of joint research, cultural, educational and artistic activities,
c. facilitate, university staff exchanges or mutual visits to both institutions,
d. exchange of scientists professors, scholars due to implementing the joint research and educational projects,
e. exchange of students in long-term or short-term programs upon mutual agreement,
f. holding joint seminars, lectures, educational workshops, and conferences.
g. the exchange of information,
h. any other activities viewed to be mutually beneficial.

This MoU becomes effective from the day the representatives of both institutions affix their signatures below, and will continue for an initial period of three years, whereupon it shall be reviewed and may be extended by the mutual written agreement of both institutions. This MoU may be revised through the mutual agreement of both institutions and may be terminated by either party upon giving six months' written notice signed by the presiding officer of the notifying party.

All financial and other arrangements as well as terms and conditions will be negotiated for each specific case/program as appropriate, and a separate MoU may be signed.
In witness to this agreement, the following individuals append their signatures:

For the Sepehr Art University in Isfahan　　　　**For the Akademia Sztuki w Szczecinie**

Rektor
Akademii Sztuki w Szczecinie

prof. dr hab. Dariusz Dyczewski

_____　　　　　　_____
Dr Hassan Ali Bakhtyar Nasrabadi　　　　　　Prof. dr hab. Dariusz Dyczewski.
The Head of Sepher Art University in Isfahan　　Rektor Akademii Sztuki w Szczecinie

Date.　　　　　　　　　　　　　　　　　　Date:

وزارت علــوم تحقیقــات و فنــاوری
شماره ثبـ ۵۸۴۸